From: Tamara Daw



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shih-Zheng Kuo

REPLY UNDER 37 CFR 116
EXPEDITED PROCEDURE
Technology Center 2600

Application No.: 10/005,784

Filed:

November 08, 2001

For: STAGGER SENSER AND

METHOD FOR IMPROVING

MODULATION

Examiner: Safaipour, Houshang

Art Unit: 2625

Response Under 37 CFR 116(b)

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Dear Sir:

Please enter the following amendments and consider the following remarks.

Amendments begin on page 2.

Remarks begin on page 6.

Please Thank 106